



U.S. Department of Commerce, Patent and Trademark Office				Attorney Docket No.: 026-0041		
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (Use several sheets if necessary)				Application No.: 10/814,816		
				Applicant(s): Ligang Zhang et al.		
				Filing Date: March 31, 2004		
				Group Art Unit: Not yet assigned		
				Date Submitted: April 30, 2004		
<b>U.S. Patent Documents</b>						
*Examiner Initial	AA	Document Number	Date	Name		
JEM	AA	5,083,236	Jan. 21, 1992	Chason et al.		
JEM	AB	5,461,353	Oct. 24, 1995	Eberhardt		
JEM	AC	6,218,729	Apr. 17, 2001	Zavrel, Jr. et al.		
JEM	AD	6,362,525	Mar. 26, 2002	Rahim		
JEM	AE	6,389,691	May 21, 2002	Rinne et al.		
JEM	AG	6,486,534	Nov. 26, 2002	Sridharan et al.		
	AH					
	AI					
	AJ					
	AK					
<b>Foreign Patent Documents</b>						
					Translation	
		Document	Date	Country	Yes	No
JEM	AL	0 675 539 A2	Oct. 4, 1995	Europe		
JEM	AM	WO 02/067326 A2	Aug. 29, 2002	PCT		
	AN					
	AP					
<b>OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)</b>						
JEM	AR	"Unitive - CSP On the Edge", Unitive Inc. 2003 (from website - <a href="http://www.unitive.com/cspedge/index.cfm">http://www.unitive.com/cspedge/index.cfm</a> ), 2 pages.				
JEM	AS	"Unitive Design Guidelines", <a href="http://www.unitive.com">www.unitive.com</a> , 2001, pp. 1-18.				
	AT					
Examiner		Date Considered				
Jennifer E. Motiwish		3-17-06				
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.						



PTO/SB/08B (Substitute for form 1449/PTO)		Attorney Docket No.: 026-0041	
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT		First Named Inventor: Ligang Zhang	
		Filing Date: March 31, 2004	
		Group Art Unit: 2811	
		Examiner Name: Jennifer E. Matisiak	
Sheet 1 of 1		Date Submitted: September 23, 2005	
NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of author (in CAPITAL LETTERS), title of article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
JEM	AA	FROMMBERGER, Michael, et al., "Integration of Crossed Anisotropy Magnetic Core Into Toroidal Thin-Film Inductors," IEEE Transactions on Microwave Theory and Techniques, Vol. 53, No. 6, June 2005, pp. 2096-2100.	
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JEM	AD	SOH, H. T., et al., "Through-Wafer Vias (TWV) and their Applications in 3 Dimensional Structures," Proceedings of 1998 International Conference on Solid State Devices and Materials, September 1998, 12 pages.	
JEM	AE	TANG, Chih-Chun, et al., "Miniature 3-D Inductors in Standard CMOS Process," IEEE Journal of Solid-State Circuits, Vol. 37, No. 4, April 2002, pp. 471-480.	
JEM	AF	TRELEAVEN, Dave and Dick James, "Integrated Circuit Passive Components," Whitepapers, Chipworks, <a href="http://www.chipworks.com/resources/resources_whitepapers.asp">www.chipworks.com/resources/resources_whitepapers.asp</a> , 4 pages.	
JEM	AG	TSUI, Hau-Yiu and Jack Lau, 2003 IEEE MTT-S Digest, pp. 225-228.	
JEM	AH	WU, Joyce H., et al., "A Through-Wafer Interconnect in Silicon for RFICs," IEEE Transactions on Electron Devices, Vol. 51, No. 11, November 2004, pp. 1765-1771.	
JEM	AI	ZANNOTH, Markus, et al., "A Fully Integrated VCO at 2 GHz," IEEE Journal of Solid-State Circuits, Vol. 33, No. 12, December 1998, pp. 1987-1991.	
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Examiner Signature	Jennifer E. Matisiak		Date Considered 3-17-06

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<sup>1</sup>Applicant's unique citation designation number (optional).

<sup>2</sup>Applicant is to place a check mark here if English language Translation is attached.